## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No. : 10/537,952 Confirmation No. 1520

Applicant : Joseph M. AMATO

Filed : June 8, 2005 TC/A II : 2829

Examiner : Tung X. Nguyen

Examiner : Tung A. Nguyen

Docket No. : US02 0574 US Customer No. : 65913

Title: RESISTOR STRUCTURES TO ELECTRICALLY

MEASURE UNIDIRECTIONAL MISALIGNMENT OF

STITCHED MASKS

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

## RESPONSE & AMENDMENT

Sir:

In response to the Office Action of Novemberl, 2006, please consider the following. A Petition for Revival of an Application for Patent Abandoned Unintentionally under 37 CFR 1.137(b) is enclosed.

Amendments to the Specification there are no amendments this paper.

Amendments to the Claims begin on page 2 of this paper.

Remarks/Arguments begin on page 4 of this paper.